Filed Electronically

PATENT APPLICATION Docket No. 15436.170.1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
Qing Deng et al.)
Serial No.: 10/695,057) Art Unit
Filed: October 28, 2003) 2828
For: WIDE TEMPERATURE F CAVITY SURFACE EMI	
Confirmation No.: 5980)
Customer No.: 022913)
Examiner: Tod Thomas Van Roy)

AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office action mailed December 20, 2006 (the "Office Action"), please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.